

WHAT IS CLAIMED IS:

1. A self-light emitting device having an EL element, comprising:

a film that is made of an inorganic material covering said EL element, and

a film that is made of an organic material covering said film made of an

inorganic material.

2. A self-light emitting device having an EL element, comprising:

a film that is made of an inorganic material in contact with said EL element, and

a film that is made of an organic material in contact with said film made of an

inorganic material.

3. A self-light emitting device having an EL element, comprising:

a film that is made of an organic material covering said EL element, and

a film that is made of an inorganic material covering said film made of an

organic material.

4. A self-light emitting device having an EL element, comprising:

a film that is made of an organic material in contact with said EL element,

and

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a film that is made of an inorganic material in contact with said film made of an organic material.

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5. A self-light emitting device according to claim 1, wherein said film made of an inorganic material is formed from silicon nitride, tantalum oxide, aluminum nitride, or carbon.

6. A self-light emitting device according to claim 2, wherein said film made of an inorganic material is formed from silicon nitride, tantalum oxide, aluminum nitride, or carbon.

7. A self-light emitting device according to claim 3, wherein said film made of an inorganic material is formed from silicon nitride, tantalum oxide, aluminum nitride, or carbon.

8. A self-light emitting device according to claim 4, wherein said film made of an inorganic material is formed from silicon nitride, tantalum oxide, aluminum nitride, or carbon.

9. A self-light emitting device according to claim 1, wherein said film made of an organic material is formed from polyamide, polyimide, acrylic resin, or benzocyclobuten.

10. A self-light emitting device according to claim 2, wherein said film made of an organic material is formed from polyamide, polyimide, acrylic resin, or benzocyclobuten.

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11. A self-light emitting device according to claim 3, wherein said film made of an organic material is formed from polyamide, polyimide, acrylic resin, or benzocyclobuten.

12. A self-light emitting device according to claim 4, wherein said film made of an organic material is formed from polyamide, polyimide, acrylic resin, or benzocyclobuten.

13. An electric appliance using said self-light emitting device according to claim 1.

14. An electric appliance using said self-light emitting device according to claim 2.

15. An electric appliance using said self-light emitting device according to claim 3.

16. An electric appliance using said self-light emitting device according to claim 4.

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17. A method of manufacturing a self-light emitting device having an EL element composed of an anode, an EL layer and a cathode,

wherein a film made of an inorganic material covering said EL element is formed using a CVD method or an evaporation method, and

wherein a film made of an organic material covering said film made of said inorganic material is formed using an ink jet method.

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18. A method of manufacturing a self-light emitting device having an EL element composed of an anode, an EL layer and a cathode,

wherein a film made of an organic material covering said EL element is formed using an ink jet method, and

wherein a film made of an inorganic material covering said film made of said organic material is formed using a CVD method or an evaporation method.

19. A method of manufacturing a self-light emitting device according to claim 17, wherein said EL layer, said cathode, said film made of said organic material, and said film made of said inorganic material are formed using the same film deposition apparatus.

20. A method of manufacturing a self-light emitting device according to claim 18, wherein said EL layer, said cathode, said film made of said organic material, and said film made of said inorganic material are formed using the same film deposition apparatus.

21. A method of manufacturing a self-light emitting device according to claim 17, wherein said EL layer and said film made of said organic material are formed by an electric field application method or an ink jet method.

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22. A method of manufacturing a self-light emitting device according to claim 18,
wherein said EL layer and said film made of said organic material are formed by an electric field
application method, or an ink jet method.

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